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Enhancing Electron Emission

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U.S. Department
of Energy



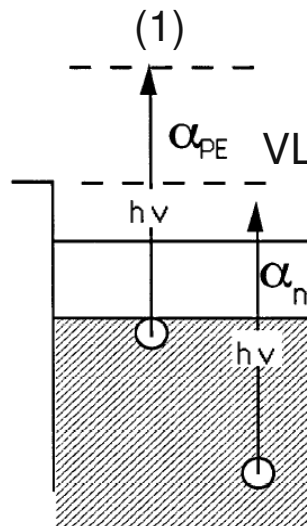
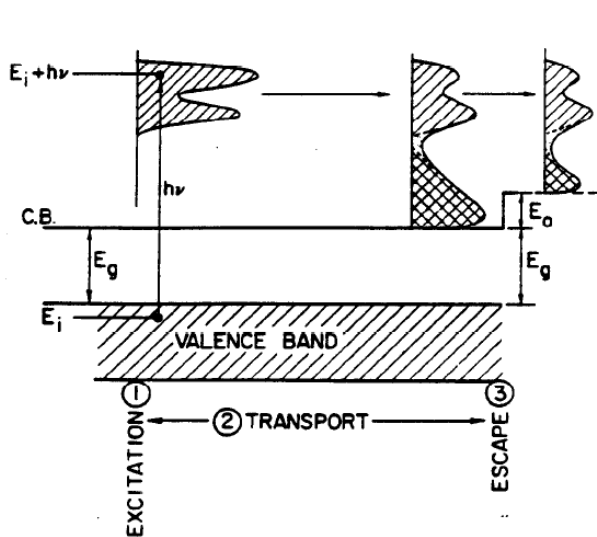
A U.S. Department of Energy laboratory
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Outline

- Introduction – Spicer's Photoemission model
- Search for new PC materials
 - Band structure of bi- and multi-alkali PC
- Electron emission enhancement
 - Anti-reflecting coatings (Nanorod Arrays, Moth-eye concept)
 - Electric field assisted PE
- MC simulation of pillar photocathode
- MC simulations of MCP test experiment
- PC lifetime, aging, ion feedback
- Summary

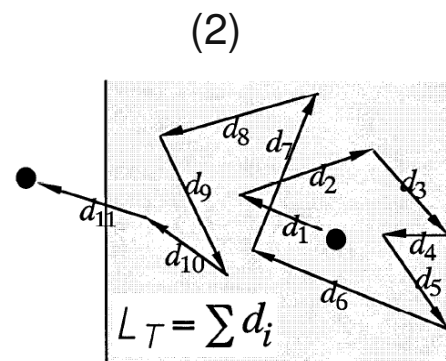
Introduction - Spicer's model



Excitation

α_{PE} - electrons are excited above the vacuum level (VL) and have possibility to escape, α_n is the absorption that does not produce yield. $\alpha_{PE}/\alpha \approx 1$ for NEA

$$QY = \frac{\alpha_{PE}}{\alpha} \cdot \frac{1}{1 + \frac{l_a}{L}} \cdot P_E$$

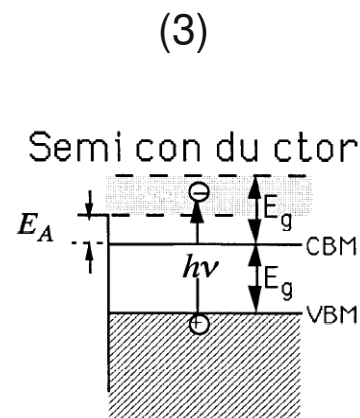


Random walk

with small loss due to collisions (~ 100 colls)
 l_a/L is an important parameter

l_a is the absorption length, L is the escape length. If $L \ll l_a$, only a small fraction of the PE contributes to the yield.

L can be obtained from experiment or by MC.



Escape to vacuum

P_E can be approximated by a step function. Usually P_E does not exceed 0.5.

[W. Spicer, Phys. Rev.112 (1958) 114]

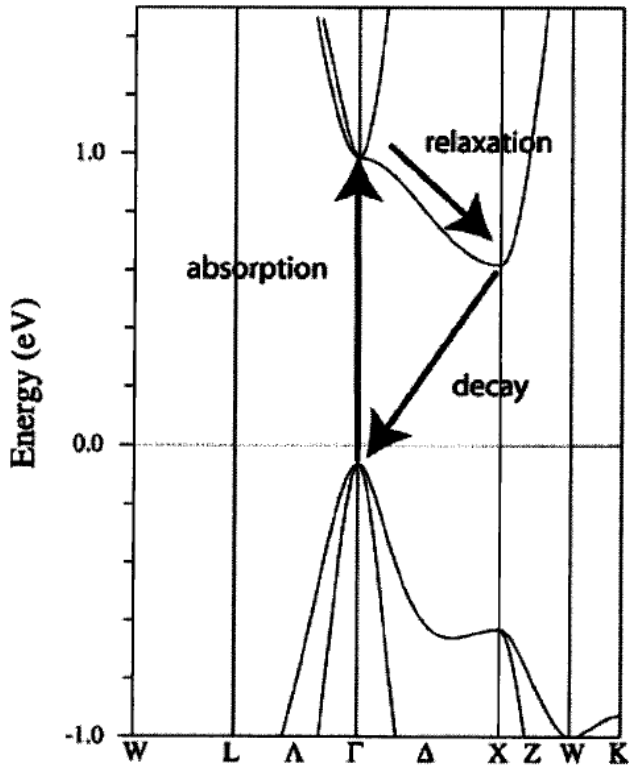
Parameters for efficient PC

- The photon absorption $\alpha=1/l_a$, E_a , E_g : Search for new materials
- The diffusion length L :
 - In UV region: $l_a/L \sim 10^4$
 - For semiconductors: $l_a/L \sim 1$
- The escape probability P_E
 - normally it is ~ 0.5
 - For CsI : ~ 1
 - For metals: < 0.1
- Field enhancement, band bending
 - (110)-Cs-O: $\Delta E=0.23\text{eV}$ (GaAs, [2])
 - (110): $\Delta E=0.28\text{eV}$
 - (111A)-Ga: $\Delta E=0.86\text{eV}$, $w = 155\text{\AA}$, $P_E=0.21$
 - (111B)-As: $\Delta E=0.1\text{eV}$, $w = 51\text{\AA}$, $P_E=0.49-0.58$
- NEA

[1] Spicer, slac-pub 6306 (1993)

[2] James et al, J. Appl. Phys. (1971)

New PC material: Li_2CsSb



- Band structure, absorption coefficient of Li_2CsSb were calculated via full potential linearized plane wave DFT-method [1].
- The direct vertical transitions generate photoelectrons.
- After relaxation to X, and it can only recombine through an indirect annihilation process with a valence band hole in Γ .

- $\Delta E_{\Gamma} = 1.05 \text{ eV}$, (red part)

- $\Delta E_X = 0.68 \text{ eV}$

- No barrier for $\Gamma \rightarrow X$

- $\alpha = 35 \mu\text{m}^{-1}$ – calculation ($l_a = 285 \text{ \AA}$)

$$\tau_{\text{indirect}} \sim 1 - 10 \text{ ms}, \text{ – from textbook}$$

$$D \sim 2.5 \times 10^{-7} \frac{\text{m}^2}{\text{s}} [2],$$

$$L \approx \sqrt{D\tau_{\text{indirect}}} \approx 15 \mu\text{m} (\text{Li}_2\text{CsSb})$$

[1] Ettema, Appl. Phys. Lett. (2003)

[2] Niigaki, ibid (1999)

Diffusion and drift of carriers

Step2: Diffusion

$$-D_{\Gamma} \frac{\partial^2 n_{\Gamma}}{\partial z^2} + \frac{n_{\Gamma}}{\tau_{\Gamma V}} = \frac{n_X}{\tau_{X\Gamma}} + J(z),$$

$$-D_{\Gamma} \frac{\partial^2 n_X}{\partial z^2} + \frac{n_X}{\tau_{X\Gamma}} = J(z).$$

z – the distance to surface,

D – diffusion coefficients,

F_{Γ}, F_X – band coefficients,

$\tau_{\Gamma V}$ – recombination times,

$\tau_{X\Gamma}$ – relaxation times,

$$Y_X = \frac{P_X F_X}{1 + (1/\alpha L_X)} (1 - R),$$

$$Y_{\Gamma} = (1 - R) \frac{P_{\Gamma}}{1 + (1/\alpha L_{\Gamma})} \left\{ F_{\Gamma} + \frac{F_X L_{\Gamma}}{\alpha L_X (L_{\Gamma} + L_X) [1 + (1/\alpha L_X)]} \right\}$$

$$L = \sqrt{D\tau} = \sqrt{\mu\tau \left(\frac{kT}{e} \right)}$$
 – the diffusion length of electrons,

μ – mobility.

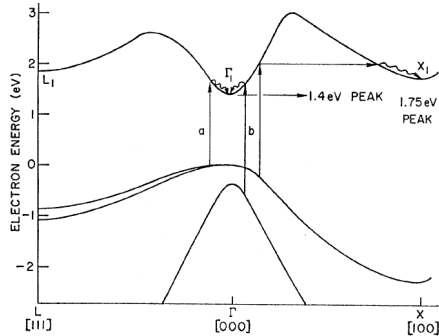
L depends on defects, dislocations, impurities.

GaAs – $L \approx 1.2\text{-}1.6 \mu\text{m}$ for $N_{\text{Zn}} = (1\text{-}3) \times 10^{19} \text{ cm}^{-3}$

Best GaAs PC [doped Ge]: $L \sim 5\text{-}7 \mu\text{m}$ [1]

[1] Eden, Mall, Spicer, Phys. Rev. Lett. (1967)

[2] James, Moll, Phys. Rev. 183 (1969)



Drift, impact ionization

$$\vec{J}_e = eD_e \nabla N_e + e\mu_e N_e \vec{E},$$

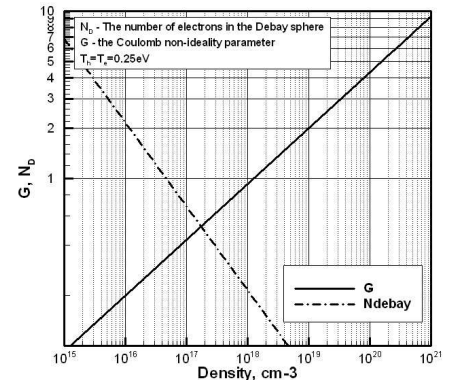
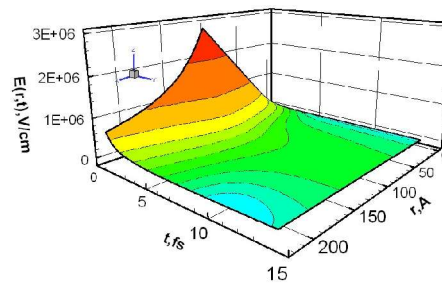
$$\vec{J}_h = -eD_h \nabla N_h + e\mu_h N_h \vec{E},$$

$$\frac{\partial N_e}{\partial t} = \frac{1}{q} \nabla J_e + G_{ii},$$

$$\frac{\partial N_h}{\partial t} = -\frac{1}{q} \nabla J_h + G_{ii},$$

$$G_{ii} = \alpha \frac{J_e}{n_e} + \left(\alpha \frac{J_h}{n_h} + \alpha \frac{J_{ch}}{n_e} \right),$$

$$\nabla^2 \varphi = \frac{e}{\epsilon \epsilon_0} (N_e - N_h - N_{ch}).$$

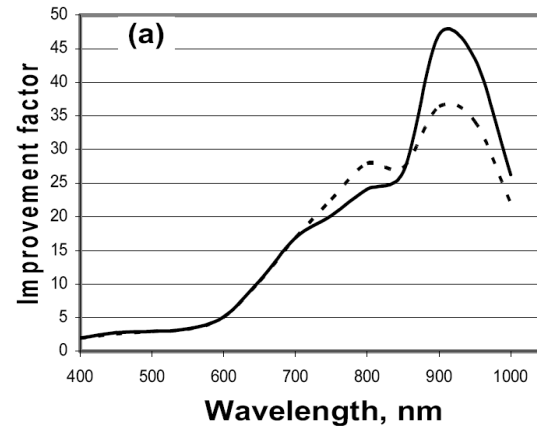


[Insepov et al, Phys. Rev. A (2008)]

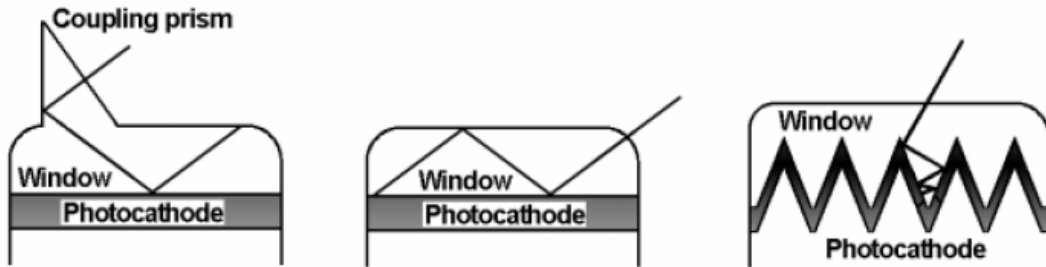
EEE: Anti-reflecting coatings

Tissue has a transparency window $\lambda=700-900$ nm that can be used for detection of breast cancer.

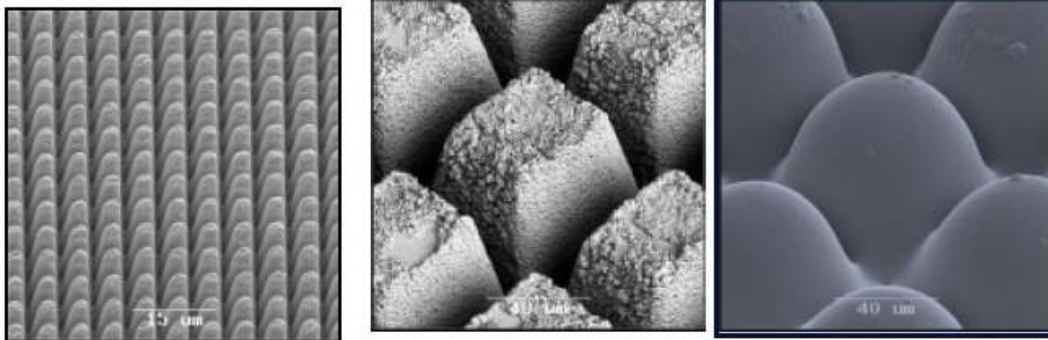
- Improvements can be done due to strong dependence of the absorbance on the impact angle.
- Surface cone design improve absorption
 - Half angles between 45 and 9 degrees give increase ~ 2 at 400 nm;
 - 8 times at 850 nm.



45 times improvement factors for two S20 photocathode tubes resulting from waveguide coupling.



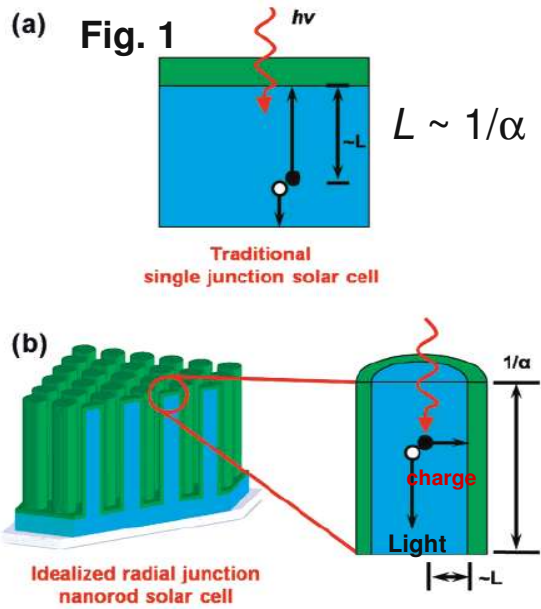
Waveguiding in the PMP window,



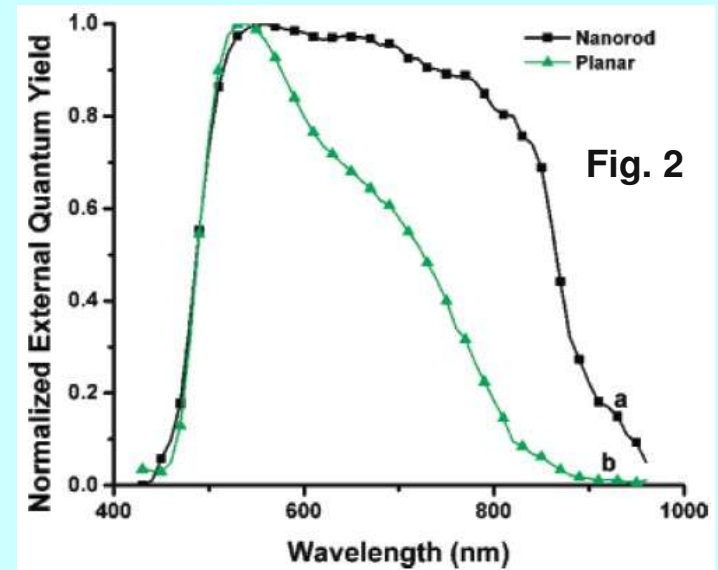
The full widths of the images are 60, 133 and 133 μm respectively.

[Downey et al, Phys. Stat. Sol. (2005)]

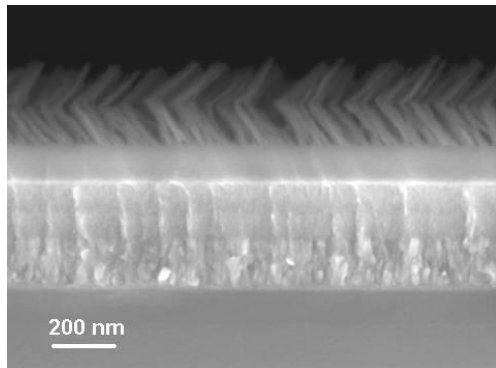
EEE: Nanorod Array layers



- Planar Cd-(Se, Te) PE vs nanorod array :
- Hi-aspect ratio nanorods could provide absorption along its axis, while collecting carriers radially (Fig. 1).
- The spectral response of the nanorod array PE exhibited better QE for collection of near-IR photons. (Fig. 2)

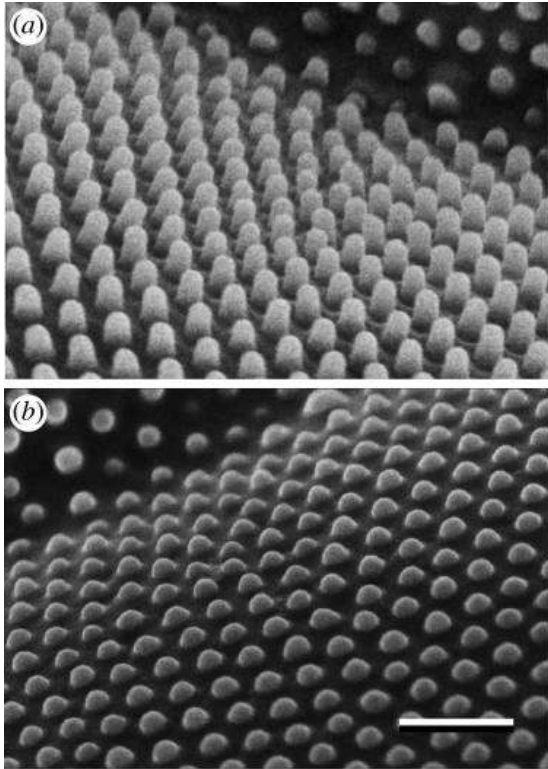
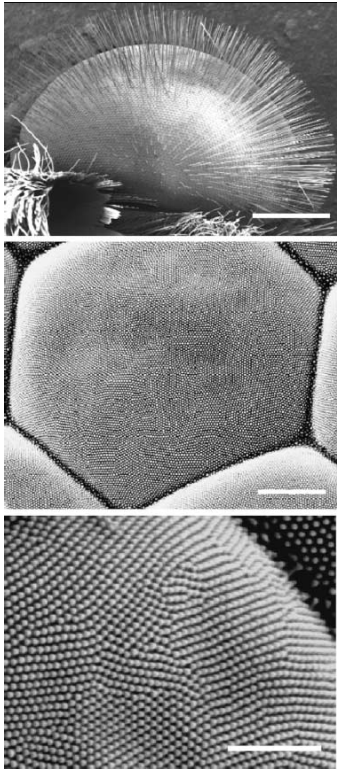


[Spurgeon et al, 2008]



- Solar cell's antireflective and all-angle coating built by seven layers, with a height of 50-100 nm, made up of SiO_2 and TiO_2 nanorods positioned at an oblique angle, absorbs 96.21% of the spectrum from UV to visible light and IR, from all angles. [Rensselaer Polytech Inst]

EEE: Moth-eye concept



- The surface of the moth eyes consists of an array of protuberances, termed corneal nipples.
- The nipples are arranged in domains with hexagonal packing, the distances are from 180 to 240 nm, the nipple heights varied between 0 and 230 nm.
- The nipples create an interface with a gradient refractive index between that of air and the lens material.
- The reflectance progressively diminished with increased nipple height. Nipples with a paraboloid shape and height 250 nm, touching each other at the base, virtually completely reduced the reflectance for normally incident light.

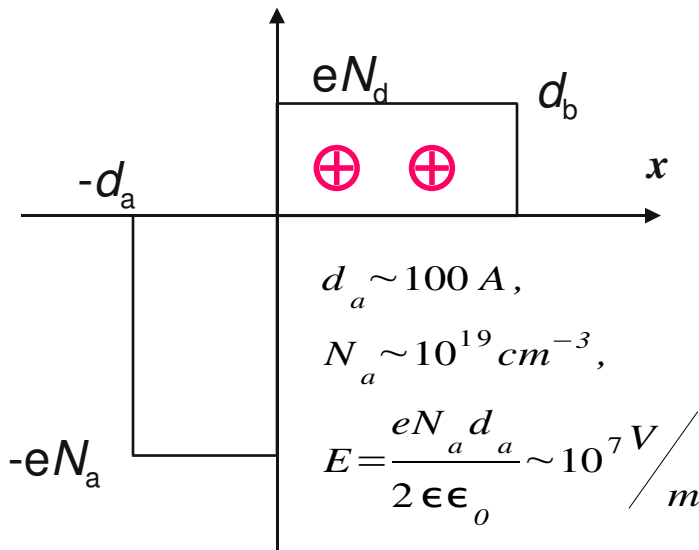
[Stavenga et al, Proc. R. Soc. B (2006)]

EEE: high electric field

■ Poisson equation
$$\frac{d^2 V(x)}{dx^2} = -\frac{\rho(x)}{\epsilon}$$

$V(x)$ the potential, ρ the charge density, and ϵ the dielectric constant

Internal electric fields:



External electric fields:

$$E = 7.9 \times 10^5 \text{ V/m [1]}$$

$$E = 4 \times 10^6 \text{ V/m [2]}$$

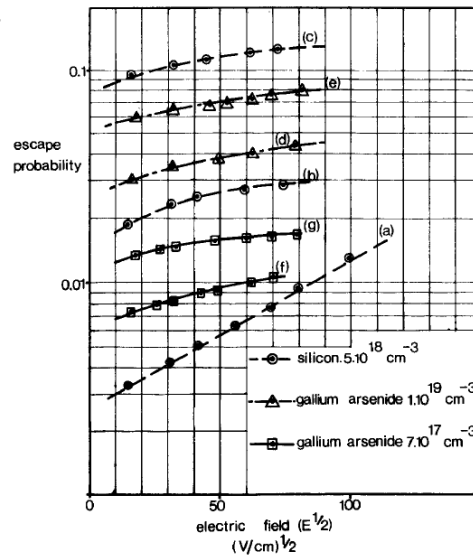
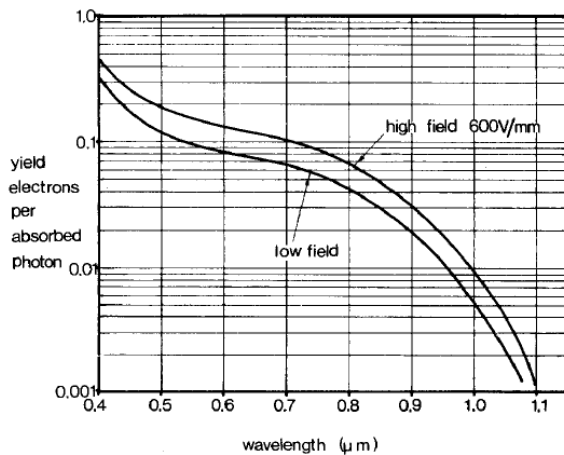
- E-field increases QE in IR
- Negative effect - dark current

[1] Crowe et al, Appl. Phys. Lett. (1967)

[2] Coleman, Appl. Opt. (1978)

Field Enhancement: Si, GaAs

- Electric field enhancement from NEA Si, GaAs was observed.
- E increases the PE and does not change the spectral response of the NEA surface.
- Surface potential lowering by the Schottky effect.



External field E reduces the work function via Schottky equation:

$$\Delta\phi = \left(\frac{eE}{4\pi\epsilon_0} \right)^{1/2},$$

$$P = \exp \left[- (B - \Delta\phi) / kT \right],$$

B – the Schottky barrier

Band bending region:

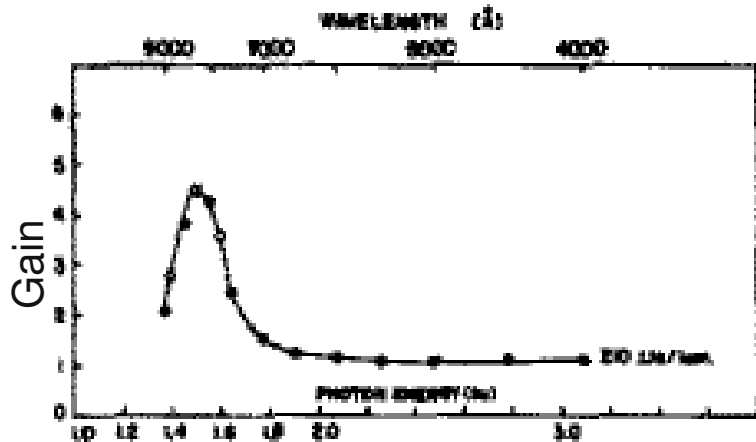
$w=200\text{\AA}$ Si : $5 \times 10^{18} \text{ cm}^{-3}$, 0.6 MV/m

$w=240\text{\AA}$ GaAs : $7 \times 10^{17} \text{ cm}^{-3}$

[Howorth et al, Appl. Phys. Lett. 1973]

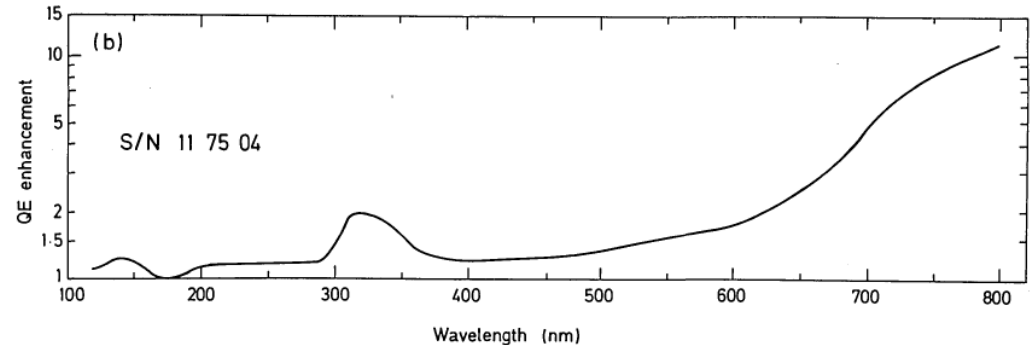
Field Enhancement: Alkali PC

- Trialkali (Cs)Na₂KSb – the electric field was applied and the magnitude of QE increase from 3 to 6 times was observed with a maximum in $\lambda = 925$ nm.
- This is due to a lowering of the potential barrier at the vacuum interface.
- Experiment [1]:
 - 1) $E = 1.3 \times 10^4$ V/m
 - 2) $E = 7.9 \times 10^5$ V/m



Photon energy, eV

- Cs₂Te photocathode was studied
- Schottky lowering explained the results for enhancement factor ~ 5 .
- $E = 4$ MV/m [2]



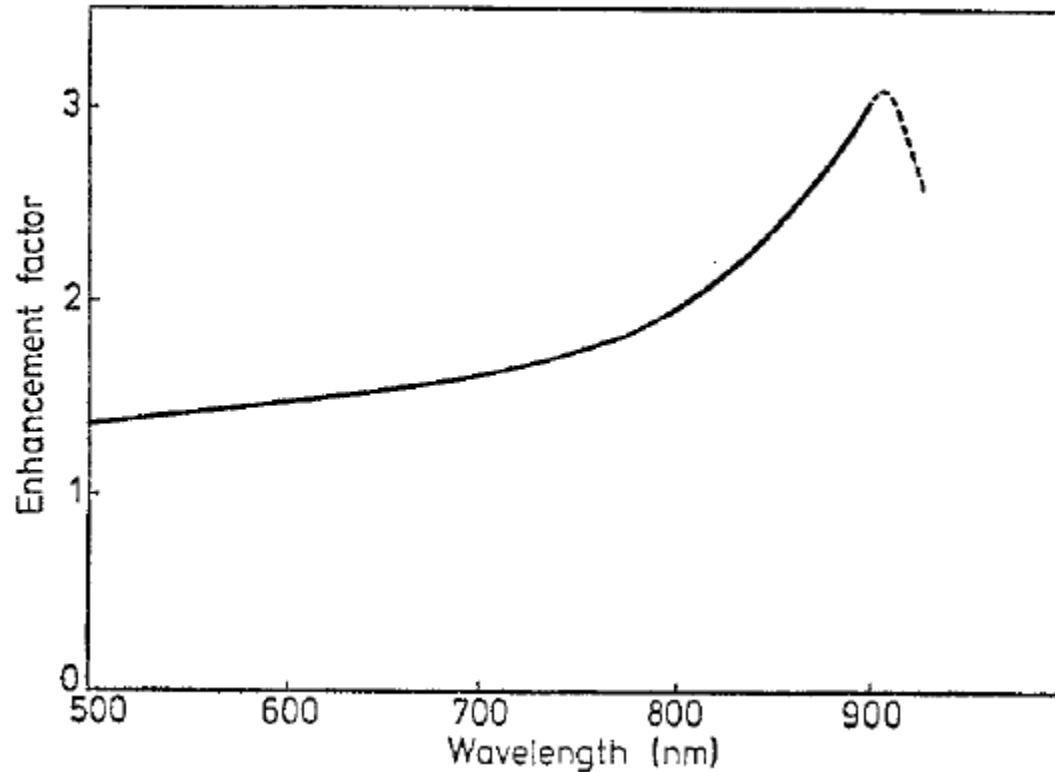
QE enhancement factor (ratio of high-field and low-field QE) as a function of wavelength.

[1] Crowe et al, Appl. Phys. Lett. (1967)

[2] Coleman, Appl. Opt. 1978

Field enhancement: Multi-alkali

- S20 and S25 photocathodes [Na₂KSb(Cs)]
- E=3 MV/m



This is consistent with a Schottky explanation and the increase in photo yield with applied field was found to obey the Schottky equation.

[Holtom, J. Phys. D (1979)]

MC study - Motivation

- Nanostructured PC surface study – MC can recreate roughness, poly- or nano-crystalline, pillar, nipple, or other metamaterial types
- Arbitrary doping, impurity and electric field simulation
- Arbitrary barrier shapes and realistic escape probability
- Testing various electron scattering models
- All materials (metals, alkaline, semiconductors)

Transport of hot electrons in metals

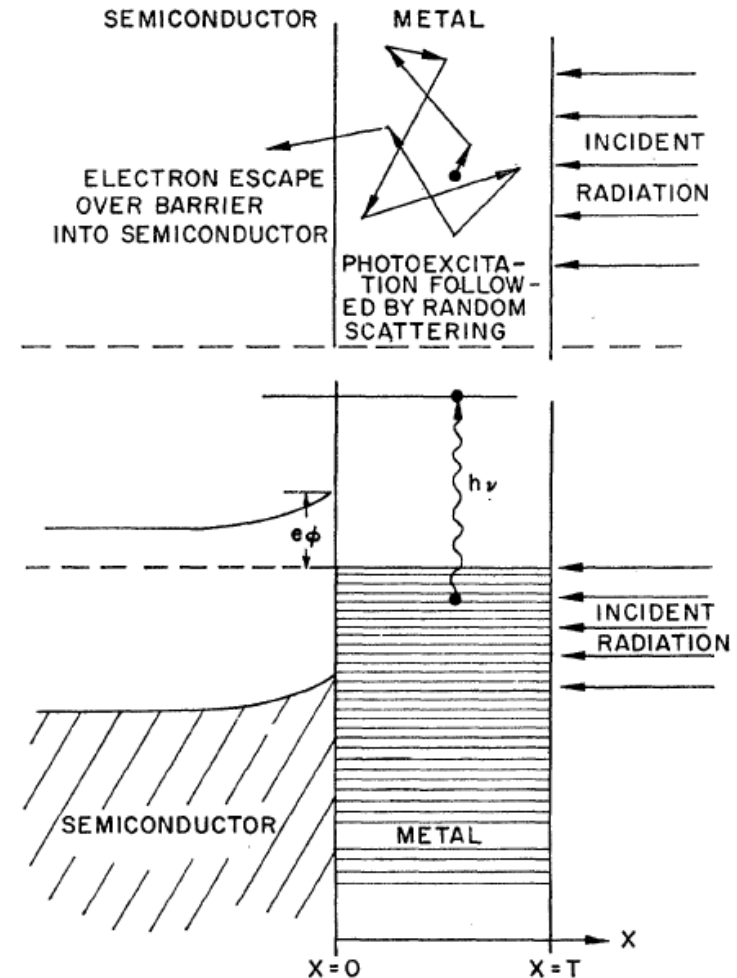
- Monte Carlo method was applied to the problem of “hot” electron motion in metals;
- e-e scattering length, e-ph length and attenuation length was obtained.
- Specular and diffuse reflectance at the boundaries were simulated.
- Comparison with the theory for Au, Ag, Pd.

Probability of e^- excited at x reach the barrier with E

$$P(x) \sim e^{-x/L}$$

By calculating the number of hot electrons crossing the barrier, for different sample thickness, the attenuation length L can be obtained.

[Stuart, Wooten, Spicer, Phys.Rev.1964]



Physical model and parameters

- (1) Photoexcitation of carriers – $I(x)=I_0 \exp(-\alpha x)$
 - exponential law with $\alpha=7.7\times 10^5 \text{ cm}^{-1}$ (typical for Au) – can be adjusted for different materials;
 - Electrons are isotropically distributed in all directions
- (2) Scattering of excited carriers;
 - $e-e$, $e-ph$ scattering $E_{\text{ph}} \approx k\theta$ (θ - Debye temperature)
 - e -impurity/defect scattering (Brooks-Herring law)
- (3) Escape of carriers over the barrier.
 - Elastic scattering interface (no energy change)
 - Lambert law in direction

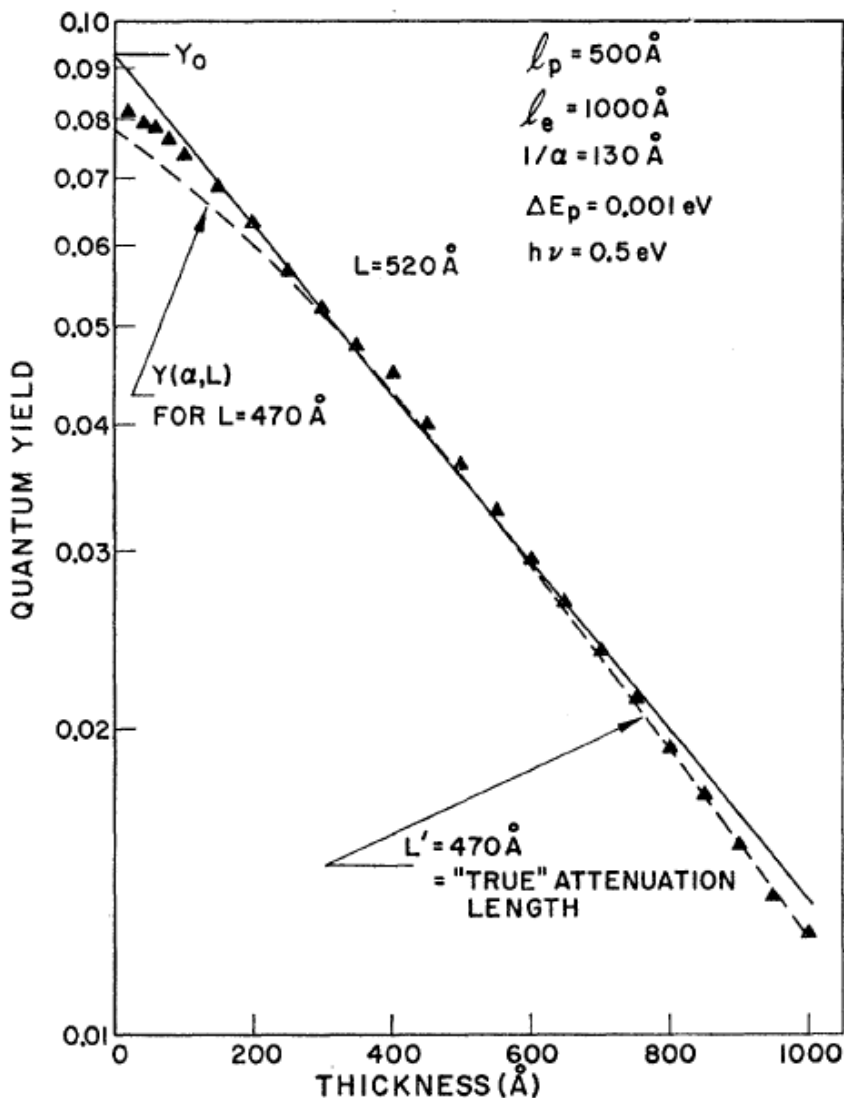
[Stuart, Wooten, Spicer, Phys.Rev.1964]

Algorithm of MC program

- Initial source of electrons $S(X,E)$ is created
 - $E = E_F + h\nu - (h\nu - e\phi)c_1$, $0 \leq c_1 \leq 1$
 - Exp attenuation: $X = T + (1/\alpha) \ln\{1 - c_2[1 - \exp(-\alpha T)]\}$,
 - T – sample thickness, $0 \leq c_2 \leq 1$
 - Collision simulation: $l_T = l_e l_p / (l_e + l_p)$ – the mean free path
 - Exp law: $l = l_T |\ln c_3|$, $0 \leq c_3 \leq 1$
 - Angle to normal: $\cos \theta = 2c_4 - 1$, $0 \leq c_4 \leq 1$ (all $d\Omega$ are eq. probable)
 - $c_5 < l_T / l_e$, $0 \leq c_5 \leq 1$ – choice for kind of collision
- New electron, new trajectory, similar to previous
 - The process continued until the electron $E < E_0$
- 10,000 trajectories computed for each sample; (statistics)
- 200, 400, 600, 800, and 1000 Å samples were simulated
- Specular reflection from the vacuum boundary

[Stuart, Wooten, Spicer, Phys.Rev.1964]

MC simulation results



- Quantum Yield vs thickness
- Comparison of MC $e-e$ mean free path l_e with experimental [1,2] and theory-I [2] and theory -II [2] with d-electrons.

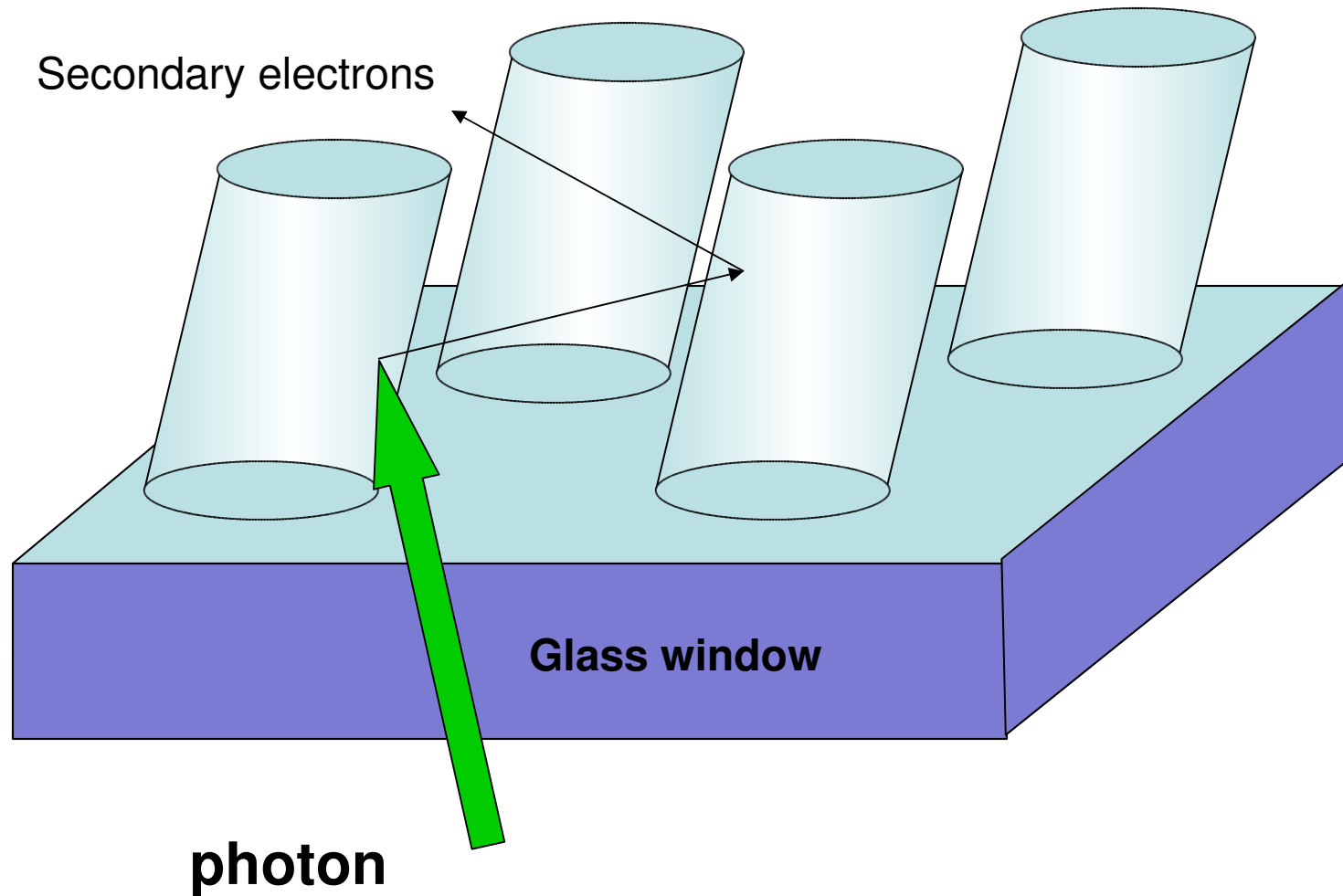
[1] Spitzer et al, Phys. Rev. (1962)

[2] Quinn, Phys. Rev. (1962)

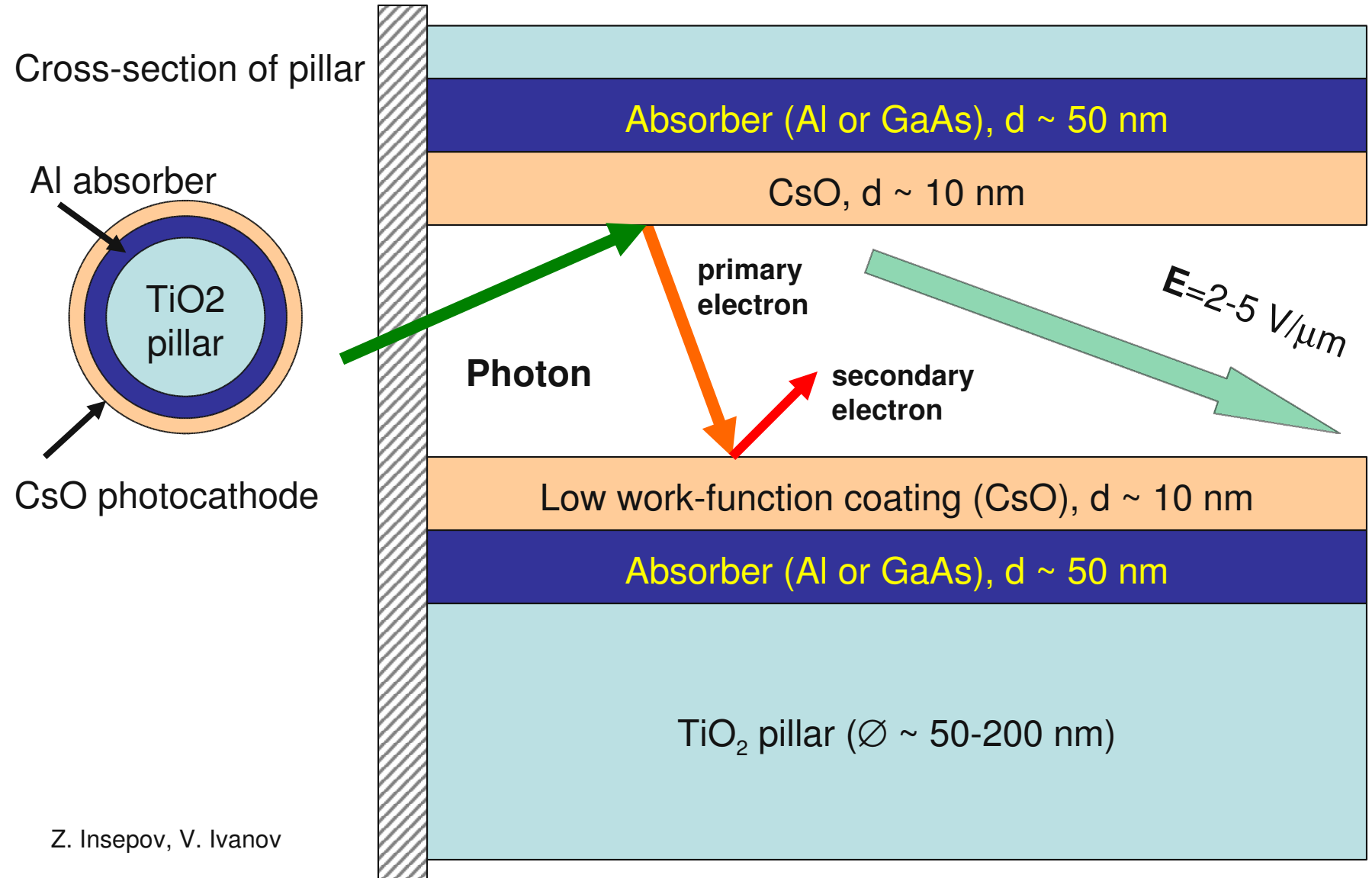
Quantum yield vs thickness for specular reflectance. Each data point – 10^5 trajectories.

[Stuart, Wooten, Spicer, Phys.Rev.1964]

Pillar structure

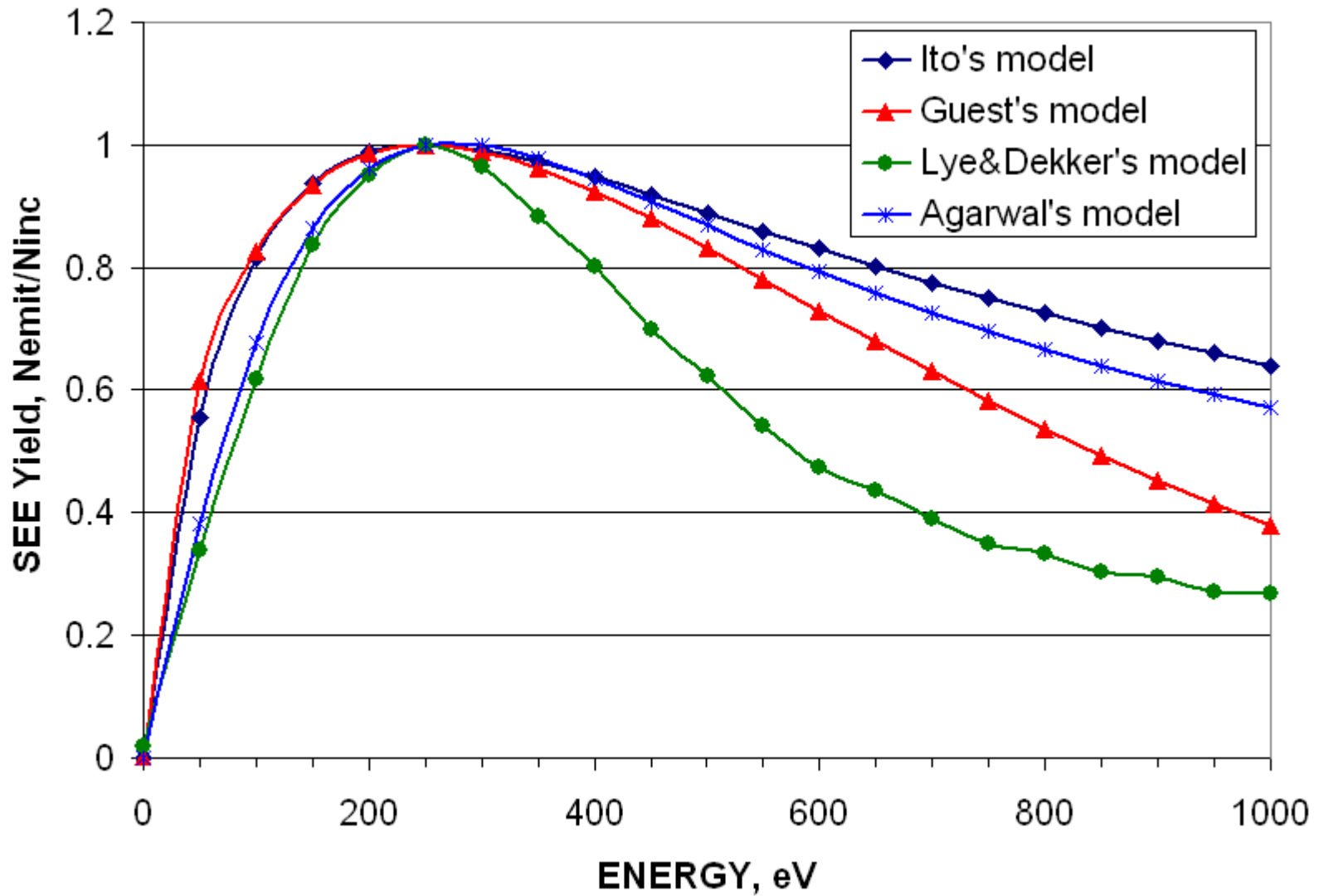


Pillar simulation



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Comparison of SEE- models



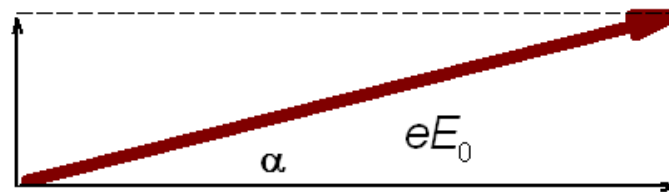
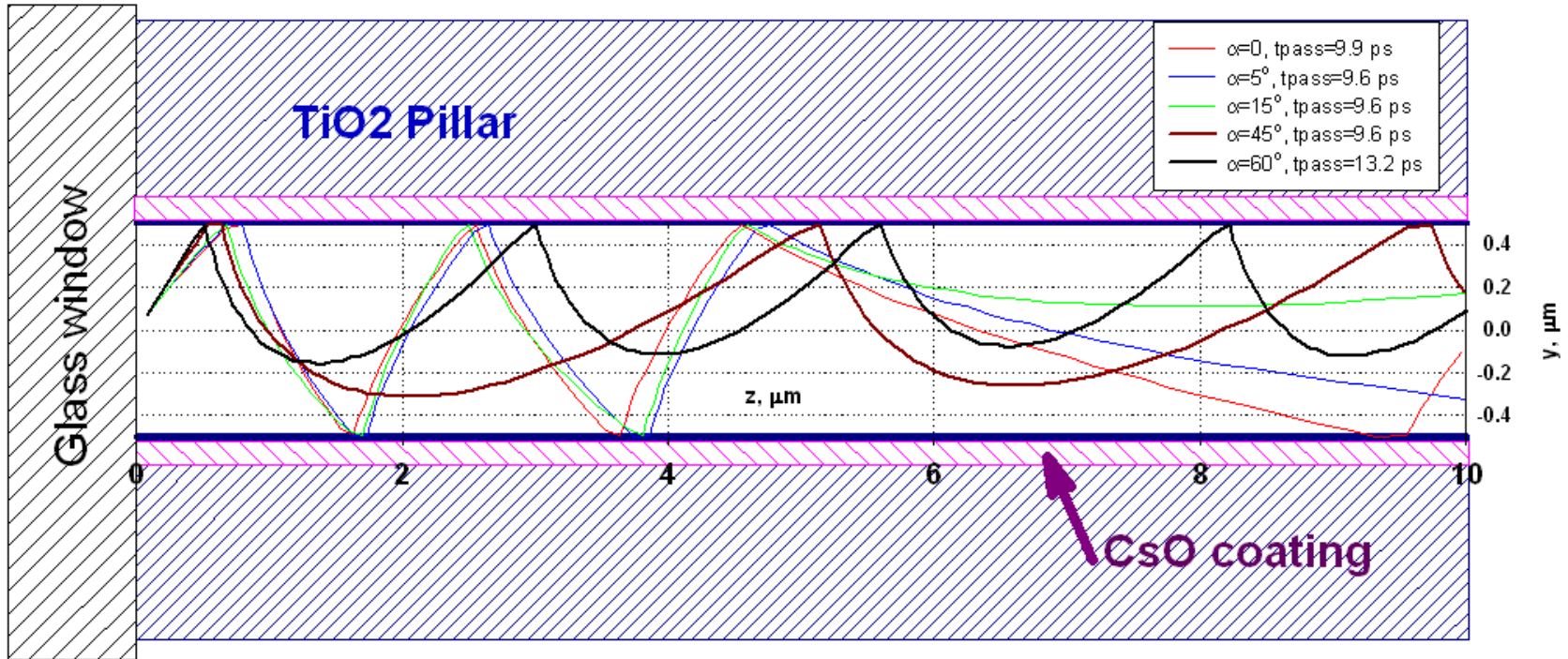
PC simulation parameters

- Photon energy : 1.5-6.2 eV (800nm-200nm)
1.4eV
- Kinetic energy of SEE: **0.5-5 eV**
- Electric field $\sim 2-5$ V/ μm accelerates *PE* to **2.5-10 eV**
- Electric field geometry is being determined by the resistivity of PC: **100 M Ω (Comsol)**

Pillar Simulation Geometry

PC size:
Diameter = 1 μm
Length = 10 μm
 $\alpha=5$ degrees

PC simulation, $E_{\text{sec}}=2$ eV, $E_0=3$ V/ μm

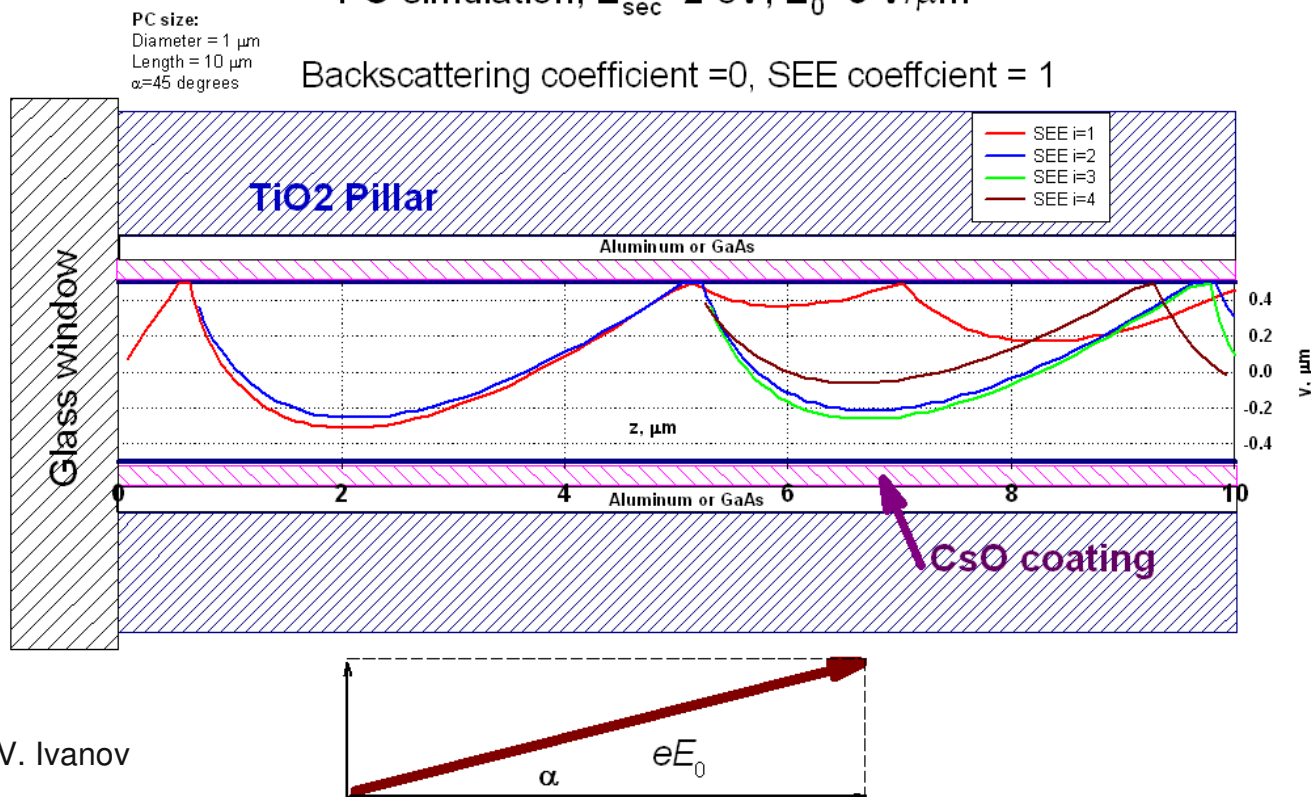


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Angular dependence of Gain, TTS

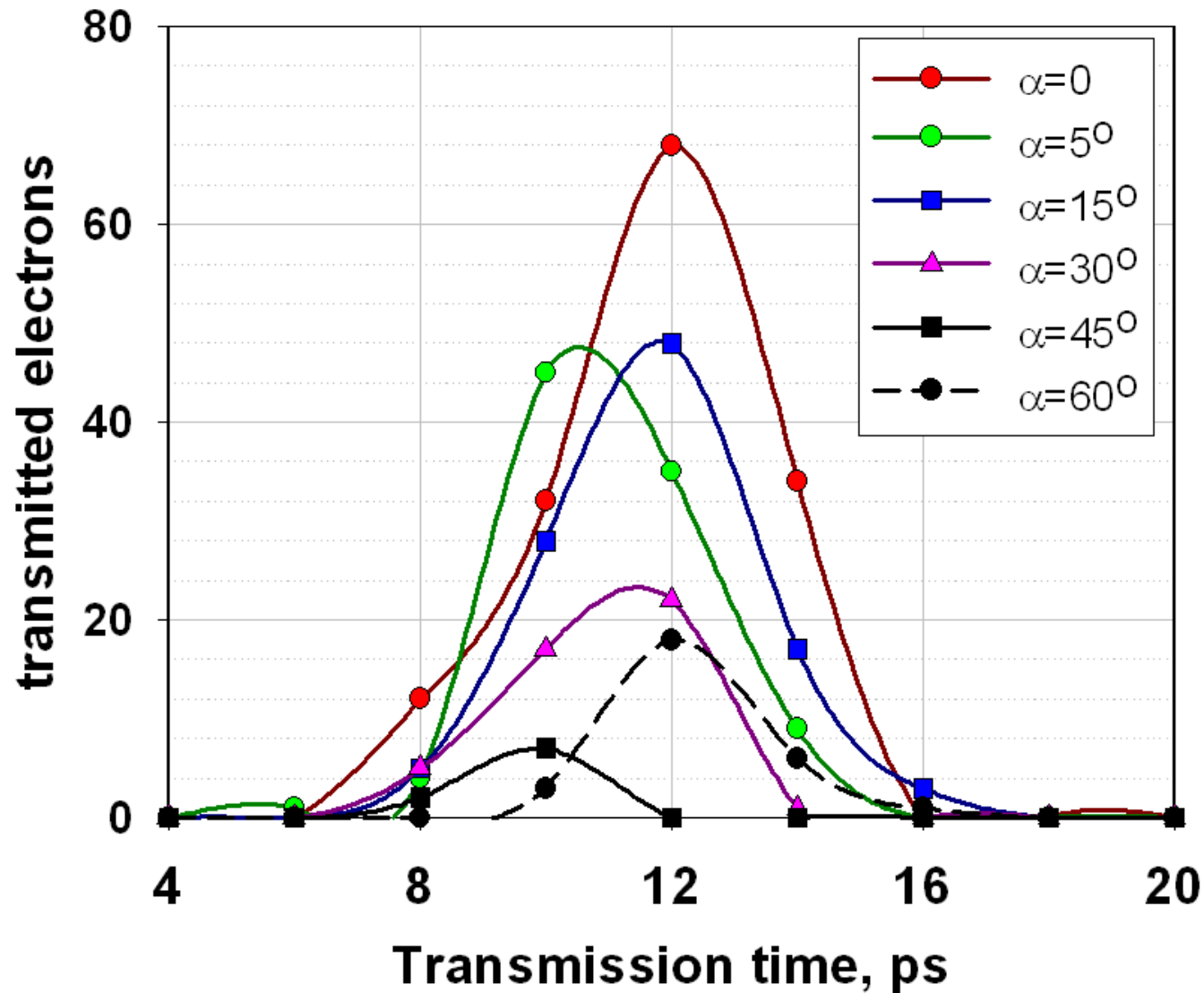
- At 45°, the electron trajectories are switching from “crossing” to “hopping” mode. This reduces the TTS value.
- At large angles, the number of collisions becomes higher and that reduces the Gain: $SEE \leq 1$ at small energies.

PC simulation, $E_{sec} = 2$ eV, $E_0 = 3$ V/ μ m



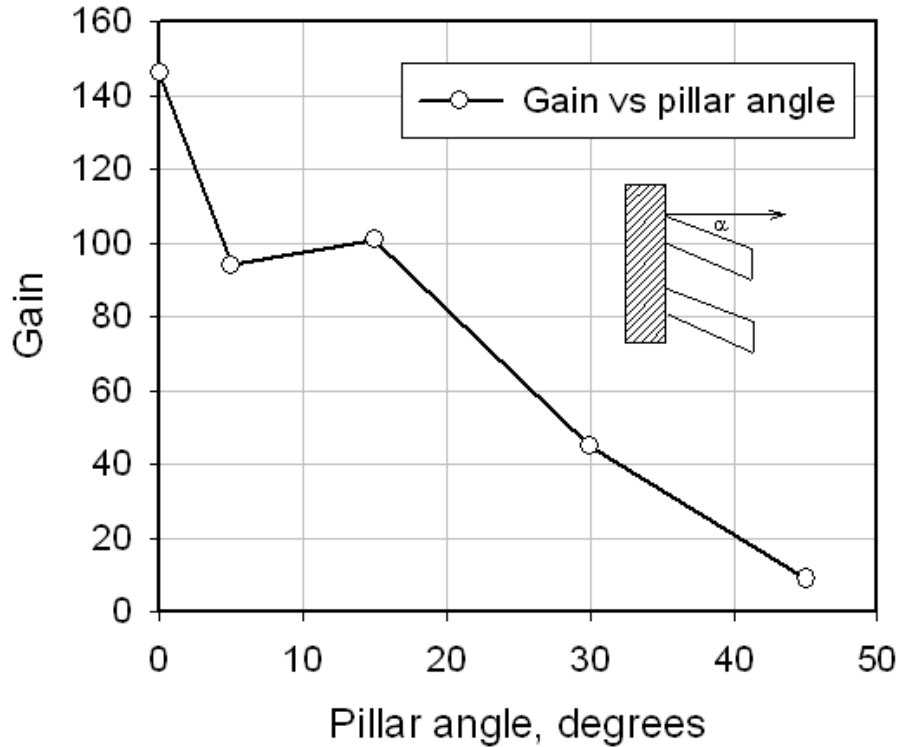
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TTS for normal and inclined pillars

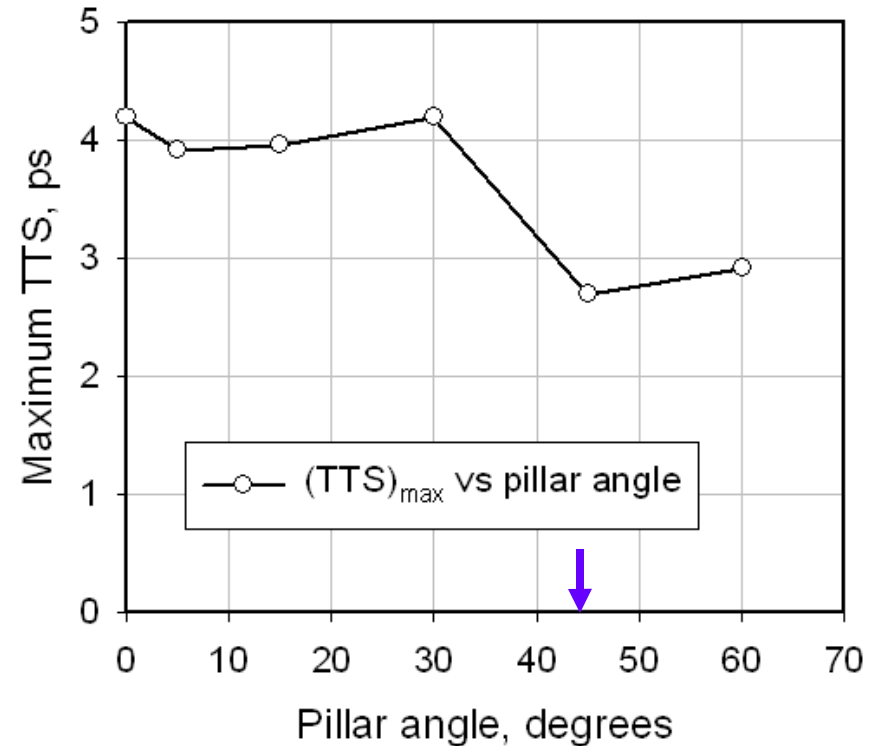


Gain and TTS vs pillar angle

Gain dependence on the pillar angle

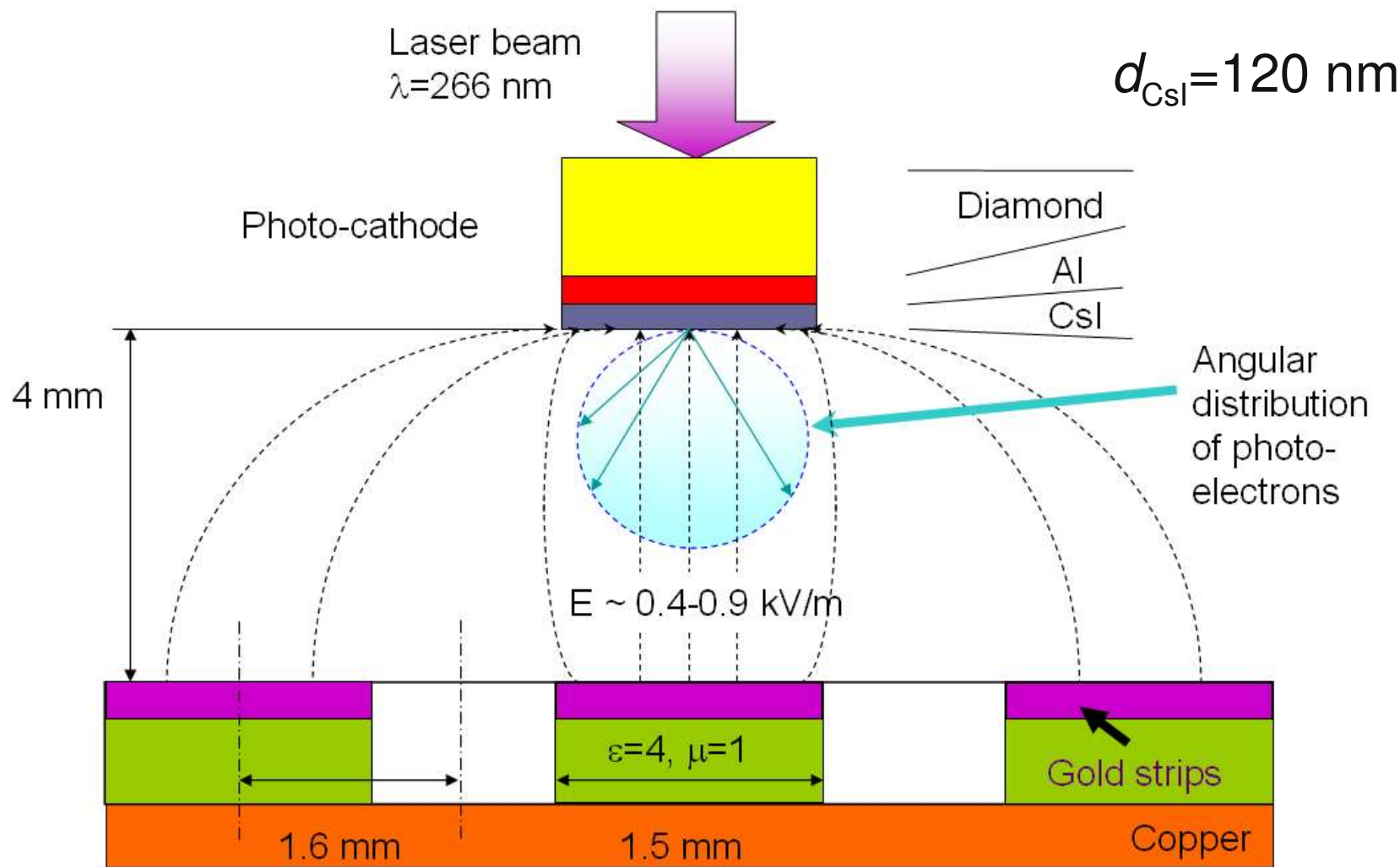


Dependence of the TTS maximum value on the pillar angle



Switching to hopping mode

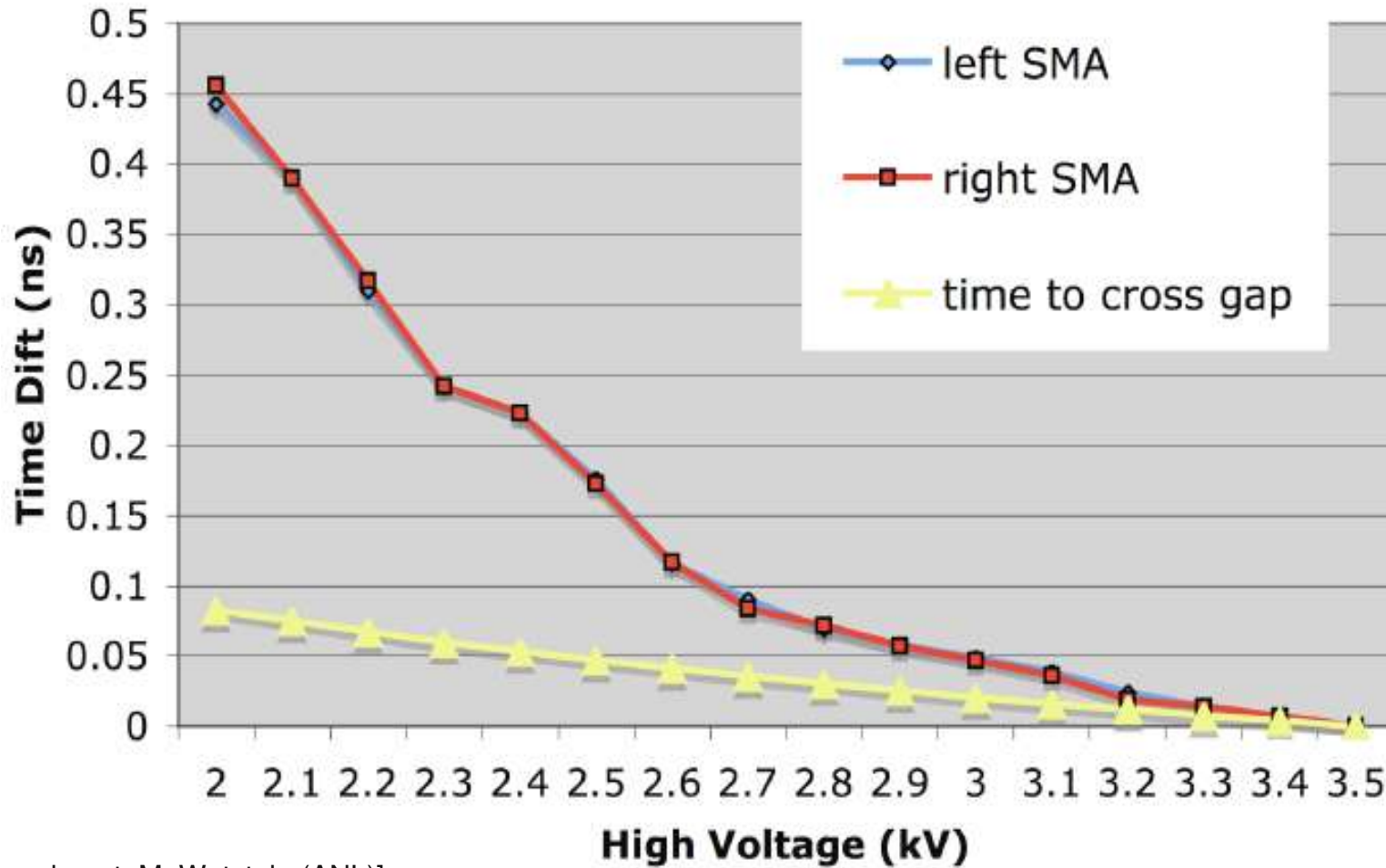
Time drift simulation for APS setup



[Experiment: M. Wetstein (ANL)]

APS experiments

Time Drift



[Experiment: M. Wetstein (ANL)]

Space-Charge Effect in PC

- The higher the number of cloud electrons per pulse N_c , the stronger is the space-charge effect.
- Non-negligible space-charge effects occur already at rather low values of N_c of about $1000e$ per pulse [1].
- APS experiments have estimated N_c per pulse $\gg 1000e$ [2].

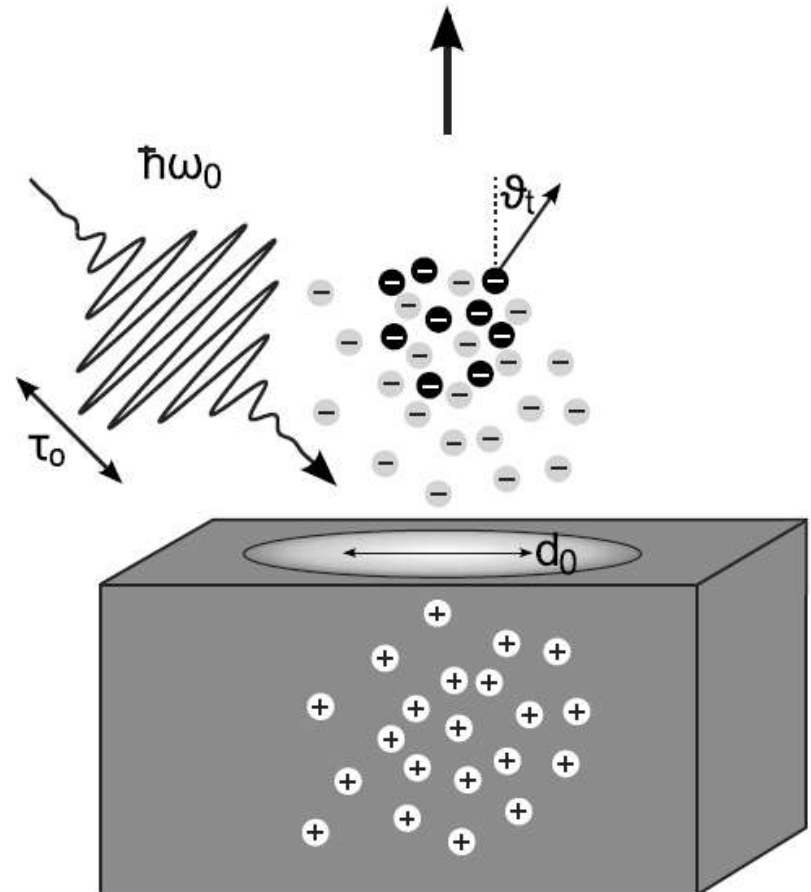
APS experimental data

$$Q = I_{\max} * \tau_0 = 140\mu\text{A} * 80 \text{ ps} = 1.12 \times 10^{-14} \text{ C}$$

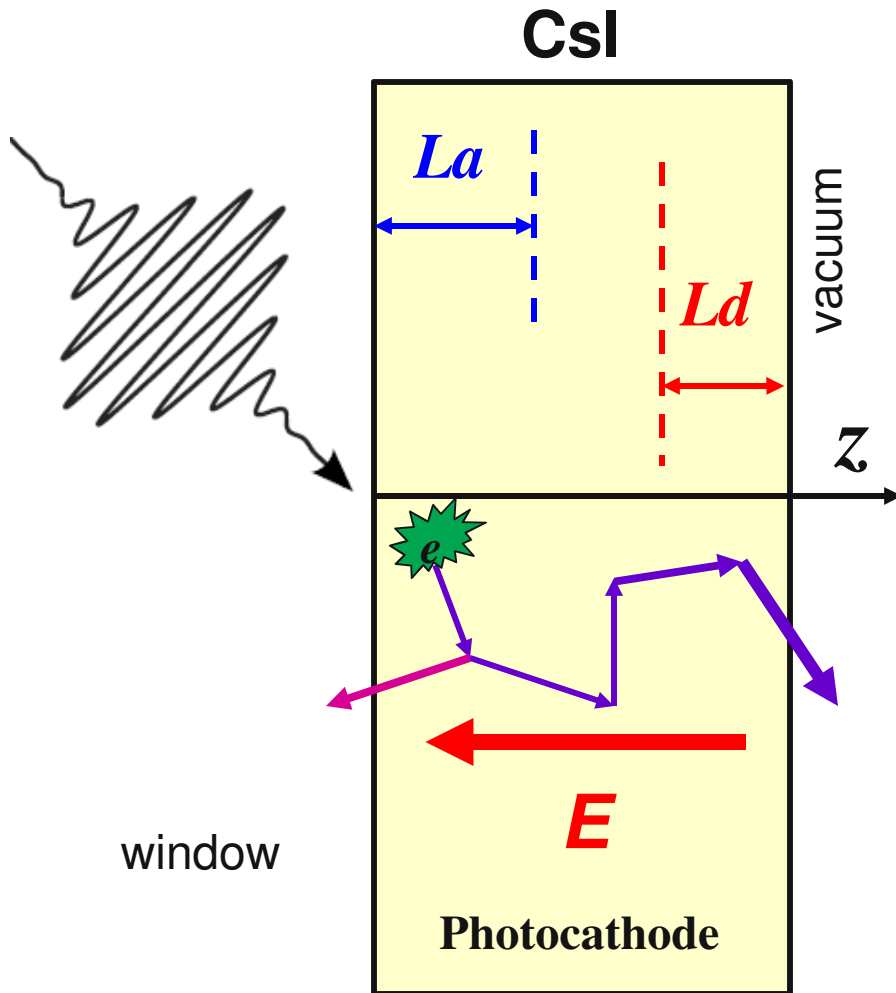
$$N_c = 7 \times 10^4 \text{ electrons per pulse [2]}$$

[1] J. Zhou et al, J. El. Spec. Rel. Phen. 2005.

[2] Matt Wetstein, ANL



MC model of random walk



$L_d - e-e + e-ph + e-defects$

$L_a = 22 \text{ nm}$, absorption length [1],

$\alpha = 1/L \approx 0.03 \text{ nm}^{-1}$,

$L_D = \sqrt{D\tau_e}$, electron diffusivity,

$L_D \sim 16 \text{ nm}$ [2],

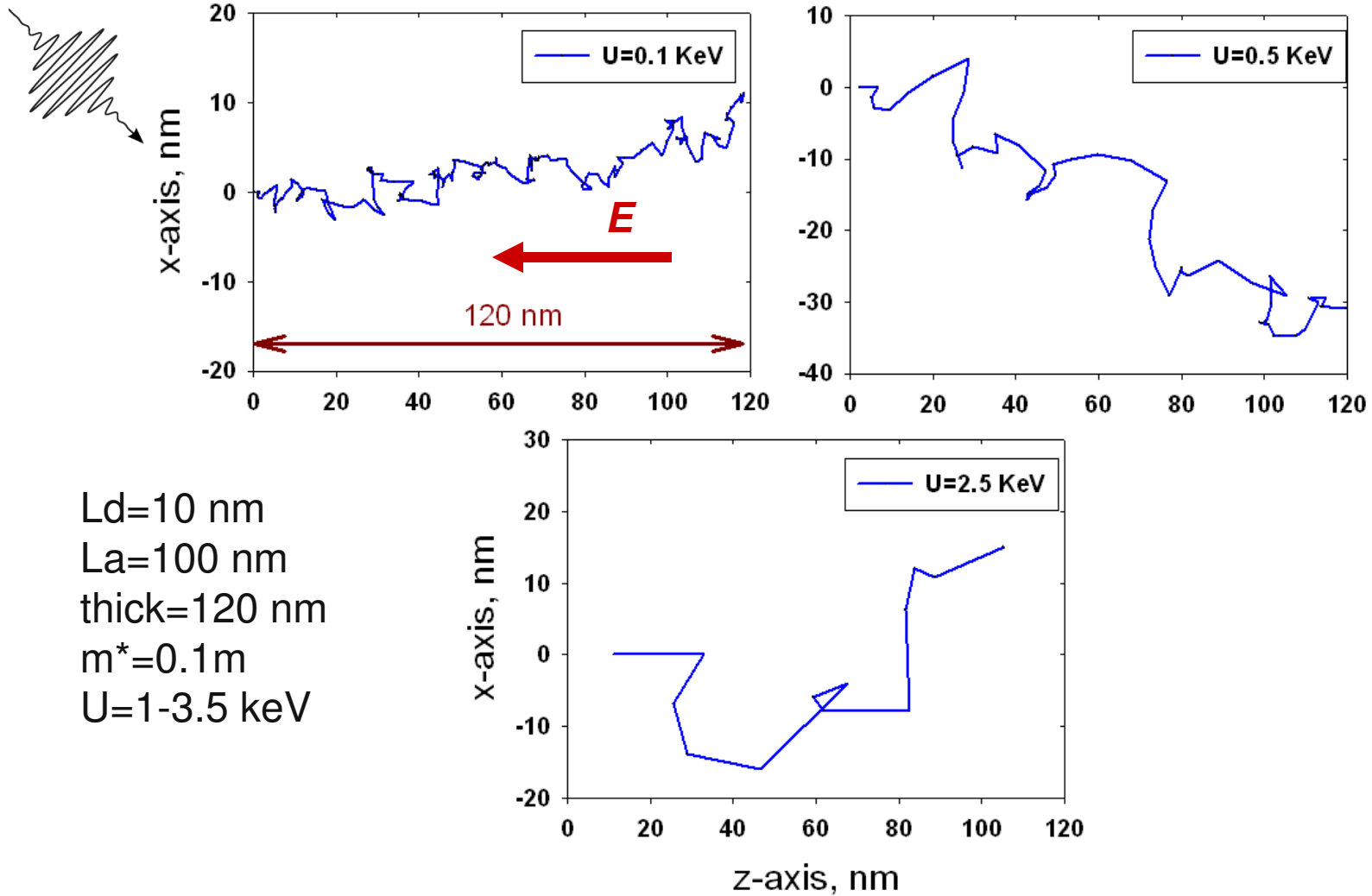
$U = 1 - 3.5 \text{ keV}$

$Y \approx (1 - R) \times QE$,

[1] Boutboul, J. Appl. Phys. (1998)

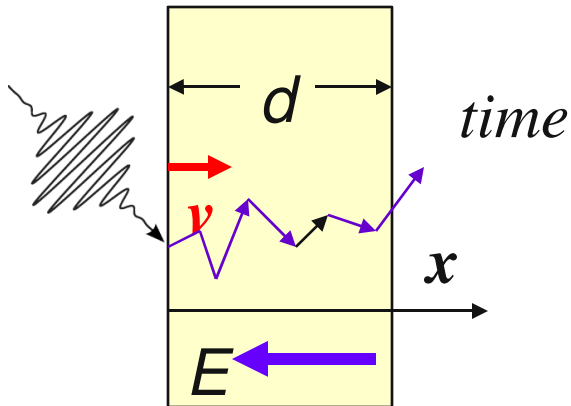
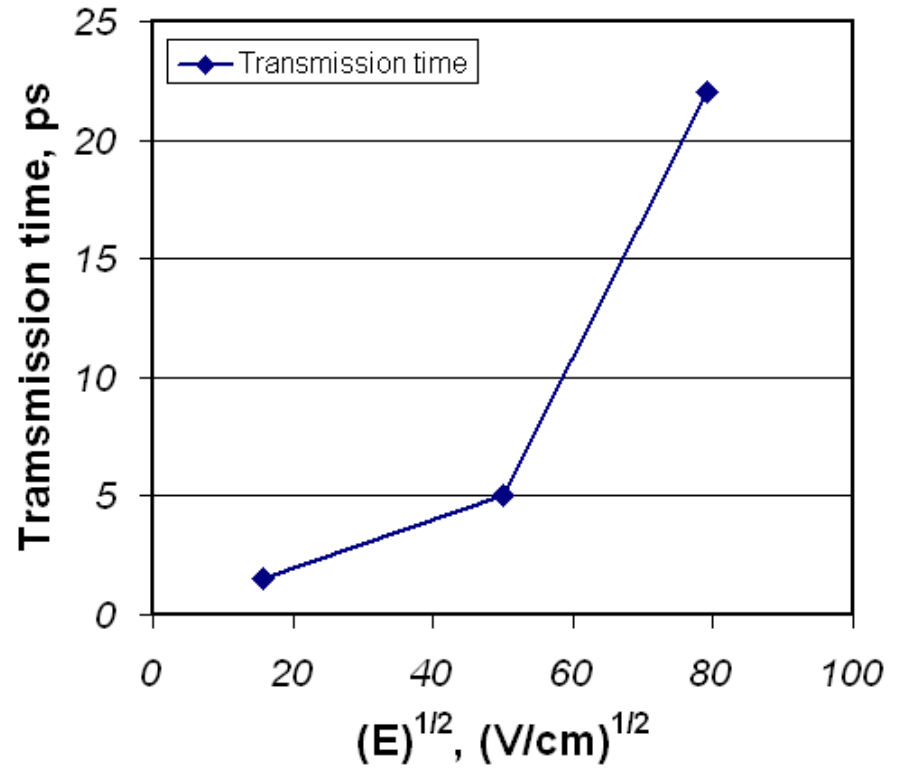
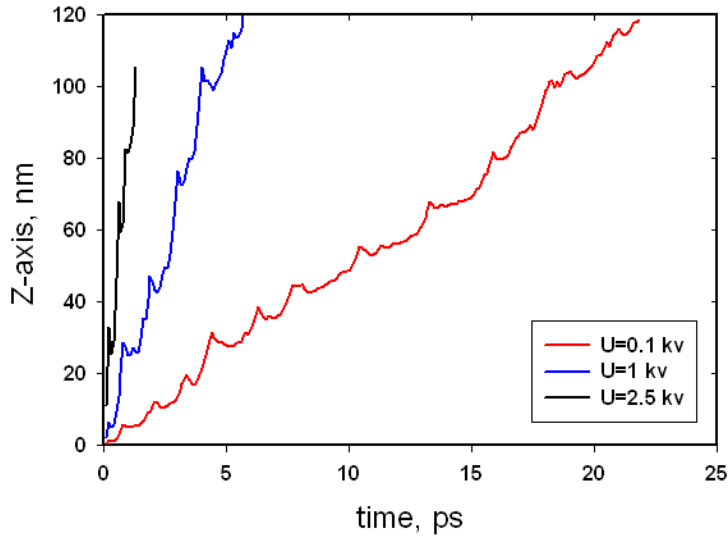
[2] Breskin, NIMA (1996)

Random walk + drift



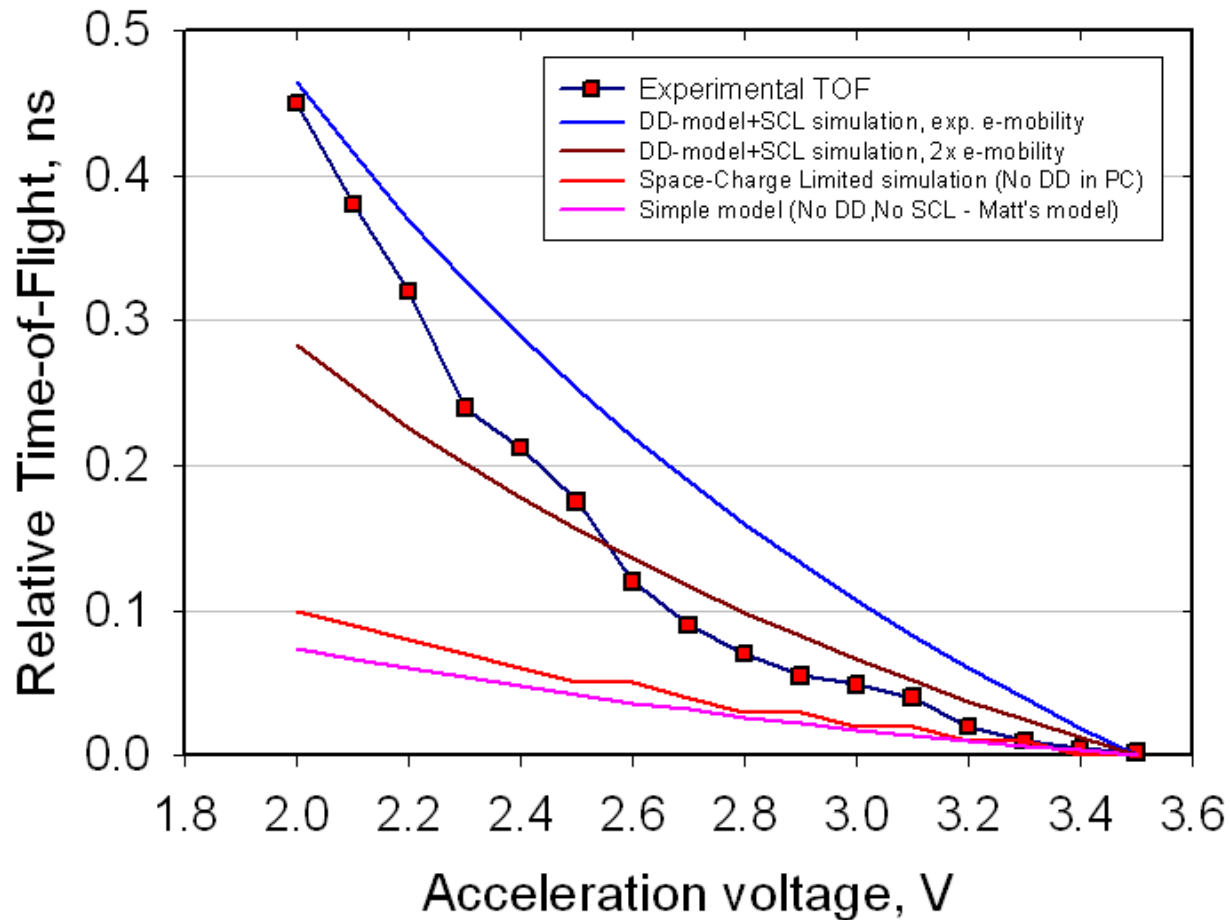
$L_d=10$ nm
 $L_a=100$ nm
thick=120 nm
 $m^*=0.1m$
 $U=1-3.5$ keV

Field dependence of TT



Time to Drift in vacuum

Drift-Diffusion model for the Time-of flight of crossing gap 4 mm



Summary

- Electron emission can be enhanced by various methods: nanostructured interfaces, doping and applying electric fields, multilayer coatings, NEA
- Theory and simulation methods are not yet capable of treating complex PC tasks, such as surface roughness, nano-structured, real material properties, hot carriers and plasma effects, high electric fields in PC, **aging**
- Nano-pillar PC structure was simulated and optimized
- MC method is being developed to evaluate surface roughness, plasma and hot electrons effects, complex materials, high electric fields and photon fluxes.

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